



**ELECTRONIC COPY**

LG650410800  
Report verification at igi.org



September 6, 2024  
IGI Report Number **LG650410800**  
Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **CUT CORNERED  
RECTANGULAR MODIFIED  
BRILLIANT**

Measurements **8.25 X 6.09 X 4.33 MM**

**GRADING RESULTS**

Carat Weight **2.01 CARATS**  
Color Grade **F**  
Clarity Grade **VS 1**

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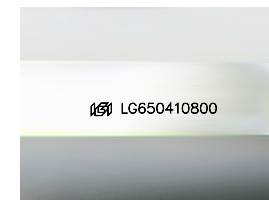
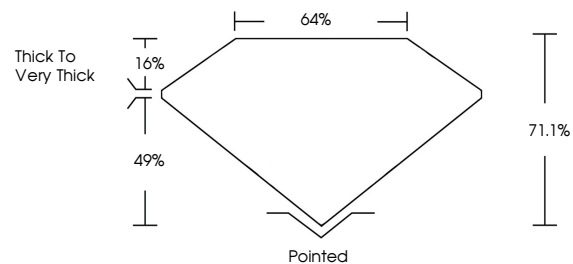
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**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG650410800**

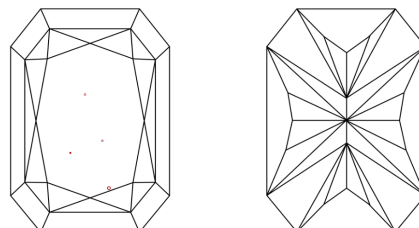
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

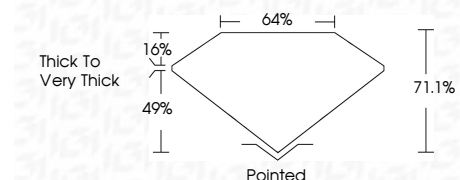
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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CUT CORNERED RECT. MODIFIED BRILLIANT  
8.25 X 6.09 X 4.33 MM  
2.01 CARATS  
F  
VS 1  
71.1%  
64%  
Thick to Very Thick  
Pointed  
EXCELLENT  
EXCELLENT  
NONE  
IGI LG650410800  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa